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(19) Europäisches Patentamt

European Patent Office

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(11) EP 1 014 143 A1

(12)

EUROPEAN PATENT APPLICATION

(43) Date of publication:

28.06.2000 Bulletin 2000/26

(51) Int. Cl.⁷: G02B 26/08

(21) Application number: 99204210.1

(22) Date of filing: 09.12.1999

(84) Designated Contracting States:

AT BE CH CY DE DK ES FI FR GB GR IE IT LI LU
MC NL PT SE

Designated Extension States:

AL LT LV MK RO SI

(30) Priority: 18.12.1998 US 216375

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(54) A multilevel mechanical grating device

(57) A mechanical grating device for improving the diffraction efficiency. The mechanical grating device is built on a base having a surface. Above the base a spacer layer, having an upper surface, is provided, and a longitudinal channel is formed in said spacer layer, said channel having a first and second opposing side wall and a bottom. A plurality of spaced apart deformable ribbon elements are disposed parallel to each other. The deformable elements are organized in groups of N elements wherein N is greater than 2. When the device is actuated each of said groups forms a pattern of discrete levels wherein the pattern has n levels wherein n is greater than 2.

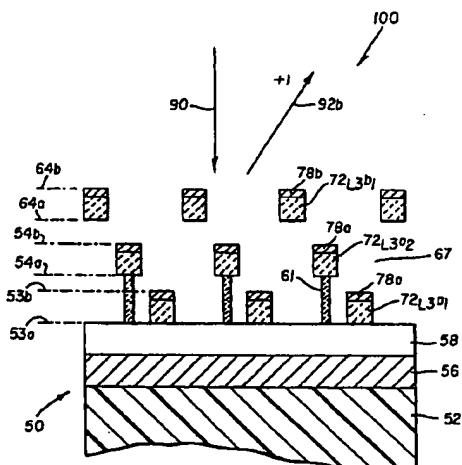


FIG. 8

EP 1 014 143 A1

Description

[0001] This invention relates to the field of modulation of an incident light beam by the use of a mechanical grating device. More particularly, this invention discloses a multilevel mechanical grating device which has a significant improvement in the output of the diffracted light beam by approximating a continuous blaze grating with m discrete levels.

[0002] Electro-mechanical spatial light modulators have been designed for a variety of applications, including image processing, display, optical computing and printing. Optical beam processing for printing with deformable mirrors has been described by L. J. Hornbeck; see U. S. Patent 4,596,992, issued June 24, 1986, entitled "Linear Spatial Light Modulator and Printer". A device for optical beam modulation using cantilever mechanical beams has also been disclosed; see U. S. Patent 4,492,435, issued January 8, 1995 to Banton et al., entitled "Multiple Array Full Width Electro-mechanical Modulator," and U. S. Patent 5,661,593, issued August 26, 1997, to C. D. Engle entitled "Liner Electrostatic Modulator". Other applications of electro-mechanical gratings include wavelength division multiplexing and spectrometers; see U. S. Patent 5,757,536, issued May 26, 1998, to Ricco et al., entitled "Electrically-Programmable Diffraction Grating".

[0003] Electro-mechanical gratings are well known in the patent literature; see U. S. Patent 4,011,009, issued March 8, 1977 to Lama et al., entitled "Reflection Diffraction Grating Having a Controllable Blaze Angle", and U. S. Patent 5,115,344, issued May 19, 1992 to J. E. Jaskie, entitled "Tunable Diffraction Grating". More recently, Bloom et al. described an apparatus and method of fabrication for a device for optical beam modulation, known to one skilled in the art as a grating-light valve (GLV); see U. S. Patent 5,311,360, issued May 10, 1994, entitled "Method and Apparatus for Modulating a Light Beam". This device was later described by Bloom et al. with changes in the structure that included: 1) patterned raised areas beneath the ribbons to minimize contact area to obviate stiction between the ribbon and substrate; 2) an alternative device design in which the spacing between ribbons was decreased and alternate ribbons were actuated to produce good contrast; 3) solid supports to fix alternate ribbons; and 4) an alternative device design that produced a blazed grating by rotation of suspended surfaces; see U. S. Patent 5,459,610, issued October 17, 1995, to Bloom et al., entitled "Deformable Grating Apparatus for Modulating a Light Beam and Including Means for Obviating Stiction Between Grating Elements and Underlying Substrate," and U. S. Patent 5,808,797, issued September 15, 1998 to Bloom et al., entitled "Method and Apparatus for Modulating a Light Beam." Bloom et al. also presented a method for fabricating the device; see U. S. Patent 5,677,783, issued October 14, 1997, entitled "Method of Making a Deformable Grating Apparatus for Modulating a Light Beam and Including Means for Obviating Stiction Between Grating Elements and Underlying Substrate".

[0004] The GLV device can have reflective coatings added to the top surface of the ribbons to improve the diffraction efficiency and lifetime of the GLV device. Preferred methods of fabrication use silicon wafers as the substrate materials requiring the device to operate in reflection for the wavelengths of interest. An increase in reflectivity is important to reduce damage of the top surface of the ribbons and avoid mechanical effects that might be attributed to a significant increase in the temperature of the device due to light absorption.

[0005] For GLV devices, the positions and heights of the ribbons have been symmetric in design. One drawback to this design is an inability to isolate the optical intensity into a single optical beam. This relatively poor optical efficiency is primarily due to the symmetry of the actuated device, which produces pairs of equal intensity optical beams. Each period of the improved grating must include more than two ribbons and create an asymmetric pattern of the ribbon heights. By creating an asymmetric pattern for the heights of the ribbons, the intensity distribution of the diffracted optical beams is asymmetric and can produce a primary beam with a higher optical intensity. Furthermore, by adjusting the asymmetry of the pattern of ribbon positions and heights, the intensity distribution of the diffracted optical beams can be altered. In this way, the device can be used to switch between various diffracted optical beams.

[0006] It is an object of the present invention to provide a mechanical grating device wherein the diffraction efficiency of a blazed grating is accomplished.

[0007] The object is achieved by a mechanical grating device comprising:

- a base having a surface;
- 50 a spacer layer having an upper surface, is provided above the base, and a longitudinal channel is formed in said spacer layer, said channel having a first and second opposing side wall and a bottom;
- a plurality of spaced apart deformable ribbon elements disposed parallel to each other and spanning the channel, said deformable ribbon elements defining a top and a bottom surface and are fixed to the upper surface of the spacer layer on each side of the channel, said deformable elements are organized in groups of N elements wherein N is greater than 2; and
- 55 each of said groups forms a pattern of discrete levels in an actuated state wherein the pattern has n levels wherein n is greater than 2.

EP 1 014 143 A1

[0008] It is a further object of the present invention to provide an electro-mechanical grating device wherein the diffraction efficiency of a blazed grating is accomplished.

[0009] The object is achieved by an electro-mechanical grating device comprising:

5 a base having a surface;
a spacer layer, having an upper surface, is provided above the base, and a longitudinal channel is formed in said spacer layer, said channel having a first and second opposing side wall and a bottom;
a first conductive layer being provided below the bottom of the channel;
10 a plurality of spaced apart deformable ribbon elements disposed parallel to each other and spanning the channel, said deformable ribbon elements defining a top and a bottom surface and are fixed to the upper surface of the spacer layer on each side of the channel, said deformable elements are organized in groups of N elements wherein N is greater than 2;
each of said groups forms a pattern of discrete levels in an actuated state wherein the pattern has n levels wherein n is greater than 2; and
15 a second conductive layer being part of each actuatable ribbon element.

[0010] An advantage of the mechanical grating device of the invention is that the position of the ribbons across the area of the substrate and the periodic sequence of the ribbon heights can be used to improve the diffraction efficiency of the optical beam. This invention presents a periodic sequence of ribbon heights that resembles a blazed grating with discrete levels and is predicted to significantly increase the optical diffraction efficiency. The multi-level mechanical grating device can be fabricated using methods that are compatible with the microelectronics industry. The device is more reliable and more appropriate for printing applications than other blazed mechanical and/or electro-mechanical gratings in the patent literature. Further advantageous effects of the present invention are disclosed in the dependent claims.

[0011] The subject matter of the invention is described with reference to the embodiments shown in the drawings.

25 Fig. 1 is an illustration of diffraction from a binary reflective grating;
Fig. 2 is an illustration of diffraction from a blazed reflective grating;
Fig. 3 is an illustration of a multi-level diffraction grating to approximate a blazed grating;
Fig. 4 is a perspective, partially cut-away view of the multilevel mechanical grating device of the present invention;
30 Fig. 5 is a top view of the multilevel mechanical grating device of the present invention;
Fig. 6 is a cross-sectional view along plane A-A indicated in Fig. 5 to illustrate the layered structure of one embodiment of the invention;
Fig. 7 is a cross-sectional view along plane B-B indicated in Fig. 5 of the three level mechanical grating device wherein no force is applied to the deformable ribbons;
35 Fig. 8 is a cross-sectional view along plane B-B indicated in Fig. 5 of the three level mechanical grating device wherein force is applied to the deformable ribbons;
Fig. 9 is a cross-sectional view along plane B-B indicated in Fig. 5 of the four level mechanical grating device wherein no force is applied to the deformable ribbons;
Fig. 10 is a cross-sectional view along plane B-B indicated in Fig. 5 of the four level mechanical grating device 40 wherein force is applied to the deformable ribbons; and
Fig. 11 shows the effect of gap width on diffraction efficiency of a two-, three- and four-level grating light valve.

[0012] Periodic corrugations on optical surfaces (i.e. diffraction gratings) are well known to perturb the directionality of incident light. Collimated light incident in air upon a grating is diffracted into a number of different orders, as described 45 by the grating equation,

$$\sin\theta_m = \sin\theta_0 + \frac{m\lambda}{\Lambda} \quad (1)$$

50 where λ is the wavelength of the light and m is an integer denoting the diffracted order. Fig. 1 illustrates a reflective grating 10 having an optical beam 12 incident on the grating 10 at an angle θ_0 11 with respect to an orthogonal axis O-O of the reflective grating 10. The grating surface is defined to have a period Λ 13, which defines the angles of diffraction according to the relation presented in Equation 1. A diffracted beam 16 corresponding to diffraction order m exits the 55 grating 10 at an angle θ_m 15.

[0013] The diffraction grating 10 pictured in Fig. 1 is a binary grating where the grating profile is a square wave. The duty cycle is defined as the ratio of the width of the groove L_1 14 to the grating period Λ 13. A binary phase grating will have the maximum diffraction efficiency when the duty cycle is equal to 0.5 and R , the reflectivity, is equal to 1.0.

EP 1 014 143 A1

[0014] For uniform reflectivity and 0.5 duty cycle, the relation presented in Equation 2 is appropriate for the calculation of the theoretical diffraction efficiency, within the accuracy of scalar diffraction theory.

$$5 \quad \eta_m = R \cos^2 \left(\frac{\pi}{\lambda} (q_m d - m\lambda/2) \right) \frac{\sin^2(m\pi/2)}{(m\pi/2)^2}, \quad (2)$$

where q_m is a geometrical factor,

$$10 \quad q_m = \cos \theta_0 + \cos \theta_m \\ = 1 + \sqrt{1 - (m\lambda/\Lambda)^2} \text{ for normal incidence } (\theta_0 = 0). \quad (3)$$

15 [0015] For normally incident illumination, the maximum efficiency in the first ($m = 1$) order occurs when the grating depth $d = \lambda/4$. Such a grating has equal diffraction efficiencies into the +1 and -1 orders of approximately 40% for the gratings of interest ($\lambda/\Lambda \leq 0.5$), while the remaining light is diffracted into higher odd orders (i.e. $\pm 3, \pm 5$, etc.).

20 [0016] For applications requiring a high optical throughput, the grating is desired to diffract with a very high efficiency into a single optical beam. It is well known to one skilled in the art that this is best accomplished by shaping the grating profile with a blaze, see C. Palmer, ed., *Diffraction Grating Handbook*, 2nd ed., (Milton Roy Instruments, Rochester, NY, 1993). Fig. 2 illustrates the continuous blazed grating profile 20 with a beam 22 incident on the plane of the grating surface 24 to produce diffracted beams 26a, 26b, 26c, 26d, 26e, 26f associated with the non-zero orders of diffraction. By proper design of the grating profile the intensity of the beam in the +1 diffracted order 26d is maximized.

25 [0017] The preferred methods of fabricating a grating device do not allow the grating profile illustrated in Fig. 2. Fig. 3 is an illustration of the grating profile that would be produced using microelectronic fabrication techniques to approximate the blaze with discrete steps wherein each step represents a separate level. The grating profile 30 is a multilevel step grating that approximates a continuous blazed grating profile 32 having a width L_2 34 and a height of separation h_2 38. Equation 4 is the scalar diffraction theory expression for the efficiency of diffraction. The number of discrete steps N within this expression defines the grating profile 30. For the GLV device, the value of the integer is selected based on 30 the period of the grating profile and the selected width of the ribbon L_2 34. The value of L_2 34 is chosen to achieve the required diffraction efficiency, but is limited to a minimum by the available fabrication methods. The value for the height h_2 38 is optimized for maximum intensity in the +1 diffracted optical beam according to the expression

$$35 \quad h_2 = \lambda/2N + p \frac{\lambda}{2}$$

where p is 0 or a positive integer.

40 [0018] The diffraction efficiency η_m into the m^{th} order for a grating with N steps tuned to the +1 order is predicted via scalar theory to be,

$$45 \quad \eta_m = \frac{R}{N^2} \left| \sum_{l=0}^{N-1} e^{i \frac{\pi l}{N} (q_m - 2m)} \right|^2 \frac{\sin^2(m\pi/N)}{(m\pi/N)^2}. \quad (4)$$

[0019] As an example of using these relationships, Table 1 shows the diffraction efficiency into the -3 through +3 orders for gratings with differing discrete steps N and R (reflectivity) equal to 1.0. With the addition of a third discrete 50 step, the grating profile becomes asymmetric and the intensity in the +1 diffracted beams 26d is increased by 70% over the power obtained for a grating profile having a square wave profile, $N = 2$. The improvement in diffraction efficiency increases with an increasing number of step levels N .

Table 1

N	η_{-3}	η_{-2}	η_{-1}	η_0	η_1	η_2	η_3
2	0.045	0	0.405	0	0.405	0	0.045

Table 1 (continued)

<i>N</i>	η_{-3}	η_{-2}	η_{-1}	η_0	η_1	η_2	η_3
3	0	0.171	0	0	0.684	0	0
4	0.090	0	0	0	0.811	0	0
5	0	0	0	0	0.875	0	0

5

[0020] For the application of the device described here to printing by photosensitive media or thermal sensitive methods, the efficiency should be maximized to allow faster rates of printing while reducing the power requirements of the optical sources providing the incident illumination. For display and other applications, increased efficiency is also advantageous. Ideally, the continuous blaze grating profile could be used to maximize the efficiency of a single diffracted order. Because of the fabrication methods chosen, the alternative of using multiple step levels is desirable. Fig. 3 illustrates a grating profile that can be produced using the standard fabrication processes of microelectronic devices.

[0021] Referring now to Fig. 4 which illustrates a perspective, partially cut-away view of the multilevel mechanical grating device 100 of the present invention. The multilevel mechanical grating device 100 disclosed therein can form at least three different levels. The mechanically deformable structures of the device 100 are formed on top of a base 50. The present embodiment as shown in Fig. 4 discloses a device 100 that can be operated by the application of an electrostatic force. Because the actuation force of the multilevel mechanical grating device 100 is electrostatic, the base 50 comprises several layers of different materials. The base 50 comprises a substrate 52 chosen from the materials glass and silicon, which is covered by a bottom conductive layer 56. In this embodiment the thin bottom conductive layer 56 is necessary since it acts as an electrode for applying the voltage to actuate the mechanical grating device 100. The thin bottom conductive layer 56 is covered by a protective layer 58. The bottom conductive layer 56 is selected from the group consisting of aluminum, titanium, gold, silver, tungsten, silicon alloys and indium tin oxide. Above the protective layer 58 a standoff layer 60 is formed which is followed by a spacer layer 65. On top of the spacer layer 65, a ribbon layer 70 is formed which is covered by a reflective layer or layers 78. The thickness and tensile stress of the ribbon layer 70 are chosen to optimize performance by influencing the electrostatic or mechanic force required for actuation and the returning force, which affects the speed, resonance frequency, and voltage requirements of the multilevel mechanical grating device 100. In the present embodiment the reflective layer 78 also has to include a conductor in order to provide electrodes for the actuation of the multilevel mechanical grating device 100. The electrodes are patterned from the reflective and conductive layer 78.

[0022] The spacer layer 65 has a longitudinal channel 67 formed therein that extends along the longitudinal direction L-L of the multilevel mechanical gating device 100. The longitudinal channel 67 comprises a first and second side wall 67a and 67b and a bottom 67c. The channel 67 is open on top and covered by a first and second set of deformable ribbon elements 72a and 72b. Each deformable ribbon element 72a and 72b spans the channel 67 and is secured to the surface of the spacer layer 65 on either side of the channel 67. The bottom 67c of the channel 67 is covered by the protective layer 58. As mentioned above, the ribbon layer 70 is covered by the reflective layer 78. The reflective layer 78 (conductive) is patterned such that there are first and second conducting regions 78a and 78b, which form comb-like structures arranged on the surface of the multilevel mechanical grating device 100 in an interdigitated manner. The first and second conductive region 78a and 78b are mechanically and electrically isolated from one another. According to the pattern of the reflective layer 78, the ribbon layer 70 is patterned to form the first and the second set of deformable ribbon elements 72a and 72b spanning the channel 67. The deformable ribbon elements 72a and 72b are grouped according to the longitudinal direction L-L of the channel 67. In the case of the three level mechanical grating device (embodiment as disclosed in Fig. 4) three deformable ribbon elements belong to one group. Each group comprises one deformable ribbon element from the second set 72b and two deformable ribbon elements from the first set 72a.

[0023] In the embodiment shown in Fig. 4, a plurality of standoffs 61 is positioned on the bottom 67c of the channel 67. The standoffs 61 are patterned from the standoff layer such that a group of standoffs 61 is associated with the deformable ribbon elements 72a and 72b of each group. In the embodiment shown here, the group of standoffs 61 is associated with the second ribbon element 72_{L3a2} of each group (valid for three ribbon elements per group). As shown in Fig. 7, each group comprises a first, second and third ribbon element 72_{L3a1}, 72_{L3a2}, and 72_{L3b1}. The standoffs 61 may also be patterned in the form of a single bar.

[0024] A top view of the multilevel mechanical grating device 100 with three levels is illustrated in Fig. 5, which also shows two planes perpendicular to the view illustrated. View Plane A-A is a side view of the multilevel mechanical grating device 100 and depicts the view shown in Fig. 6. View Plane B-B is a side view of the device and depicts the view shown in Fig. 7. Note that a device with four or more levels (four or more deformable ribbon elements per group) is a straightforward extension of the principles illustrated in Figs. 5, 6 and 7.

[0025] The mechanical grating device 100 as shown in Fig. 5, is a device which can be actuated by the application of an electrostatic force. It is clear that a person skilled in the art can imagine other ways for actuating the grating device,

for example thermal actuation, piezoelectric actuation or any combination. In the embodiment shown in Fig. 5, a first and a second electrically conducting region 78a and 78b are formed on the surface of the mechanical grating device 100. The first and the second electrically conducting region 78a and 78b are electrically and mechanically isolated from each other to allow the application of different voltages to the first and second sets of deformable ribbon elements 72a and 72b.

5 The first conducting region 78a applies the voltage to the first set of deformable ribbon elements 72a and the second conducting region 78b provides the voltage to the second set of deformable ribbon elements 72b. The second conducting region 78b is in contact with the bottom conductive layer 56 (see Fig. 6) designated at the base 50 through at least one etched opening 74 filled with the thick conductive layer 76. For operation of the device, the electrostatic force is produced by a voltage difference between the bottom conductive layer 56 and the conducting layer 78 atop the ribbon layer 70. Ideally the conducting layer 78 is highly reflective to maximize the optical diffraction efficiency when operating the device. The connection with the bottom conductive layer 56 is carried out by an interconnect 75. The thin bottom conductive layer 56 is formed below the bottom 67c of the channel 67. From the view of Fig. 5, regions of the spacer layer 65 and protective layer 58 are visible because of patterning of first and second conductive region 78a and 78b to achieve electrical and mechanical isolation of the deformable ribbon elements 72a and 72b.

10 [0026] The device presented here is a GLV that incorporates multiple levels, which means more than two, to discretely approximate a blazed grating. Figs. 7 and 8 illustrate this concept with three levels, and Figs. 9 and 10 illustrate the concept with four levels.

[0027] In Fig. 7, the surface 53a of the substrate is shown with pedestals or lines as standoffs 61 designed with specific heights as defined by the relationship between the height h_2 34 and the number of ribbons N per group. For this case, the value of N is three for the group which represents one period Λ . The first ribbon element of each group is designated 72_{L3a1}, the second ribbon element of each group is designated 72_{L3a2} and the third ribbon element of each group is designated 72_{L3b1}. The first and second ribbon element 72_{L3a1} and 72_{L3a2} of each group are contacted by the first conductive region 78a or, in other words, the first and second ribbon elements 72_{L3a1} and 72_{L3a2} of each group belong to the first set of deformable ribbon elements 72a. The third ribbon element 72_{L3b1} of each group is contacted by the second conductive region 78b or the third ribbon element 72_{L3b1} of each group belongs to the second set of deformable ribbon elements 72b. The height of the intermediate level is defined by standoff 61 which is associated with the second ribbon element 72_{L3a2} of each group. In the unactuated state (no applied force) all the ribbon elements 72a and 72b are coplanar, defining a first top level 64b and a first bottom level 64a. The unactuated multilevel mechanical grating device 100 acts like a mirror and an incident light beam 90, having a wave-length λ , is reflected into the 0th order. The reflected light beam in the 0th order is designated 92a. In the actuated state (Fig. 8) the deformable ribbon elements 72a of the first set are subjected to a deformation which draws the ribbon elements into the channel 67. The ribbon elements 72b of the second set are not subjected to any deformation. Therefore every third ribbon element 72_{L3b1} of each group remains in the unactuated state thereby defining the first top level 64b and the first bottom level 64a. The second ribbon element of each group abuts against the standoff 61, thereby defining a first intermediate top level 54b. The first element 72_{L3a1} of each group is moved to the bottom of the channel 67, defined by surface 53a, thereby defining a bottom top level 53b. Each top level 64b, 54b and 53b is spaced by $\lambda/2N$ above the surface 53a to maximize the efficiency of diffraction into the +1 order. The diffracted beam is designated 92b.

[0028] Although the ribbons in each group are actuated to different depths, each does not have to be independently addressed by the driver circuitry. The presence of standoffs to define the height 54a enables the device to operate as designed with all moving ribbons receiving the same voltage and initial electrostatic force. Thus, only two independent voltage levels are required to operate a device with improved efficiency, ground voltage and operating voltage. This is equivalent to the requirement of the device designs of prior art.

[0029] In Figs. 9 and 10, in which $N = 4$, the lower standoff height 61 is $\lambda/8$ and the upper standoff height 62 is $\lambda/4$. The total depth of the channel should be $(1 - 1/N)\lambda/2$. For this case, the value of N is four for a group which represents one period Λ . The first ribbon element of each group is designated 72_{L4a1}, the second ribbon element of each group is designated 72_{L4a2}, the third ribbon element of each group is designated 72_{L4a3} and the fourth ribbon element of each group is designated 72_{L4b1}. The heights of the intermediate levels are defined by standoffs 61 which are associated with the second and third ribbon element 72_{L4a2} and 72_{L4a3} of each group. The standoff 61 associated with the second ribbon element 72_{L4a2} defines a surface 54a. The standoff 61 associated with the third ribbon element 72_{a3} defines a surface 55a. In the unactuated state (no applied force) all the ribbon elements 72a and 72b are coplanar, defining a first top level 64b and a first bottom level 64a. The unactuated multilevel mechanical grating device 100 acts like a mirror and an incident light beam 90, having a wavelength λ , is reflected into the 0th order. The reflected light beam in the 0th order is designated 92a. In the actuated state (Fig. 10) the deformable ribbon elements 72a of the first set are subjected to a deformation which draws the ribbon elements into the channel 67. The ribbon elements 72b of the second set are not subjected to any deformation. Therefore every forth ribbon element 72_{L4b1} of each group remains in the unactuated state thereby defining the first top level 64b and the first bottom level 64a. The third ribbon element 72_{L4a3} of each group abuts against the standoff 61, defining the surface 55a, thereby defining a first intermediate top level 55b. The second ribbon element 72_{L4a2} of each group abuts against the standoff 61, defining the surface 54a, thereby defining a second

intermediate top level 55b. The first element 72_{L4a1} of each group is moved to the bottom of the channel 67, defined by surface 53a, thereby defining a bottom top level 53b. Each top level 64b, 55b, 54b and 53b is spaced by $\lambda/2N$ above the surface 53a to maximize the efficiency of diffraction into the +1 order. The diffracted beam is designated 92b.

[0030] As discussed previously, the optical efficiency of the device can theoretically be increased by up to 70% for 5 a 3-level grating or 102% for a 4-level grating, assuming ideal reflectors and ignoring effects from inter-ribbon gaps. Note that, while more levels yields higher diffraction efficiencies in the ideal grating, the presence of gaps between ribbons degrades the performance of 3- and 4-level gratings relative to that of 2-level gratings. Furthermore, the additional 10 levels will increase the number of processing steps required to create the standoffs 61. Fig. 11 shows a plot of the theoretical diffraction efficiency of the 1st-order beam as a function of the percent ratio of gap width L_G to the ribbon width L_R , within the accuracy of scalar diffraction theory. In practice, with an optimized device, the ratio L_G / L_R can be between 10% and 30% and the corresponding 3- and 4-level gratings still provide a significant improvement in diffraction efficiency. Thus, the ideal number of ribbons per period, N , is probably either three or four, depending on the minimum feasible size of the gaps between the ribbons and the allowed pixel width.

[0031] The invention has been described in detail with particular reference to certain preferred embodiments 15 thereof, but it will be understood that variations and modifications can be effected within the spirit and scope of the invention.

Claims

20 1. A mechanical grating device comprising:

a base having a surface;
a spacer layer, having an upper surface, is provided above the base, and a longitudinal channel is formed in
25 said spacer layer, said channel having a first and second opposing side walls and a bottom;
a plurality of spaced apart deformable ribbon elements disposed parallel to each other and spanning the channel, said deformable ribbon elements defining a top and a bottom surface and we fixed to the upper surface of
30 the spacer layer on each side of the channel, said deformable elements are organized in groups of N elements
wherein N is greater than 2; and
each of said groups forms a pattern of discrete levels in an actuated state wherein the pattern has n levels
35 wherein n is greater than 2 so as to present a periodic sequence of ribbon heights that resembles a blazed grat-
ing.

2. The mechanical grating device as recited in claim 1 has a plurality of standoffs provided, and according to the lon-
gitudinal direction of the device at least N-2 standoffs are associated with each group.
35 3. The mechanical grating device as recited in claim 2 wherein the standoffs are formed on the bottom of the channel.
4. The mechanical grating device as recited in claim 2 wherein the standoffs are formed on the bottom surface of the
ribbon elements.
40 5. The mechanical grating device as recited in claim 2 wherein according to the width of said device each standoff is
divided into a plurality of individual elements of equal height.
6. The mechanical grating device as recited in claim 1 wherein in the actuated state the levels of adjacent ribbon ele-
45 ments in each group are separated by

$$\frac{\lambda}{2N} + p\frac{\lambda}{2},$$

50 wherein λ is the wavelength of light; N is the number of discrete steps; and p is 0 or a positive integer.

7. The mechanical grating device as recited in claim 6 wherein in the actuated state the levels of successive ribbon
elements in each group are reduced by a constant amount with respect to the bottom of the channel, and thereby
55 representing a staircase of equal steps.
8. The mechanical grating device as recited in claim 1 wherein said side walls are substantially vertically disposed
with respect to the bottom.

EP 1 014 143 A1

9. The mechanical grating device as recited in claim 1 wherein said channel has a constant cross section along the entire length of the device.

5 10. The mechanical grating device as recited in claim 1 wherein a reflective layer is provided on the top surface of the ribbon elements.

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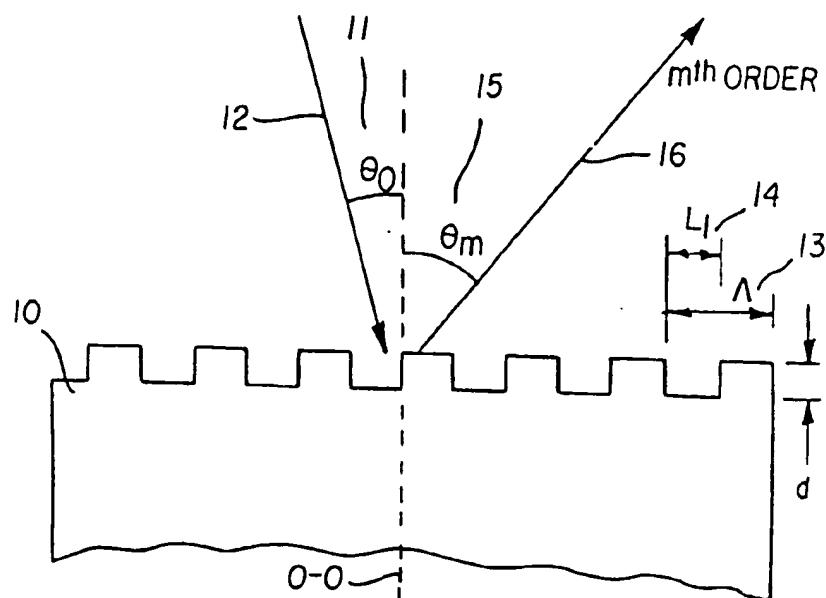


FIG. 1

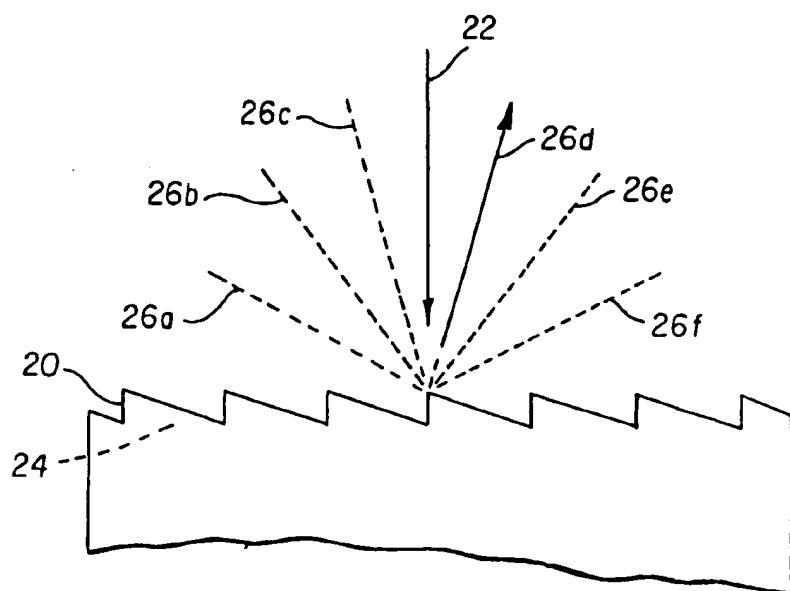


FIG. 2

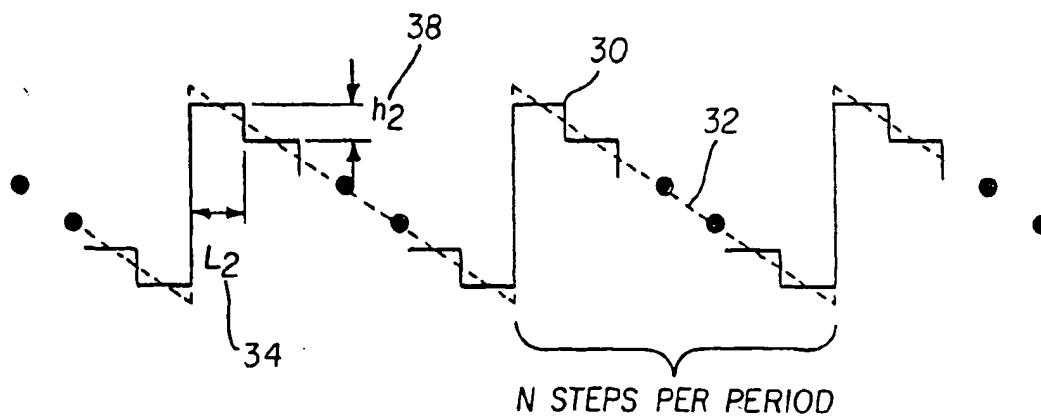


FIG. 3

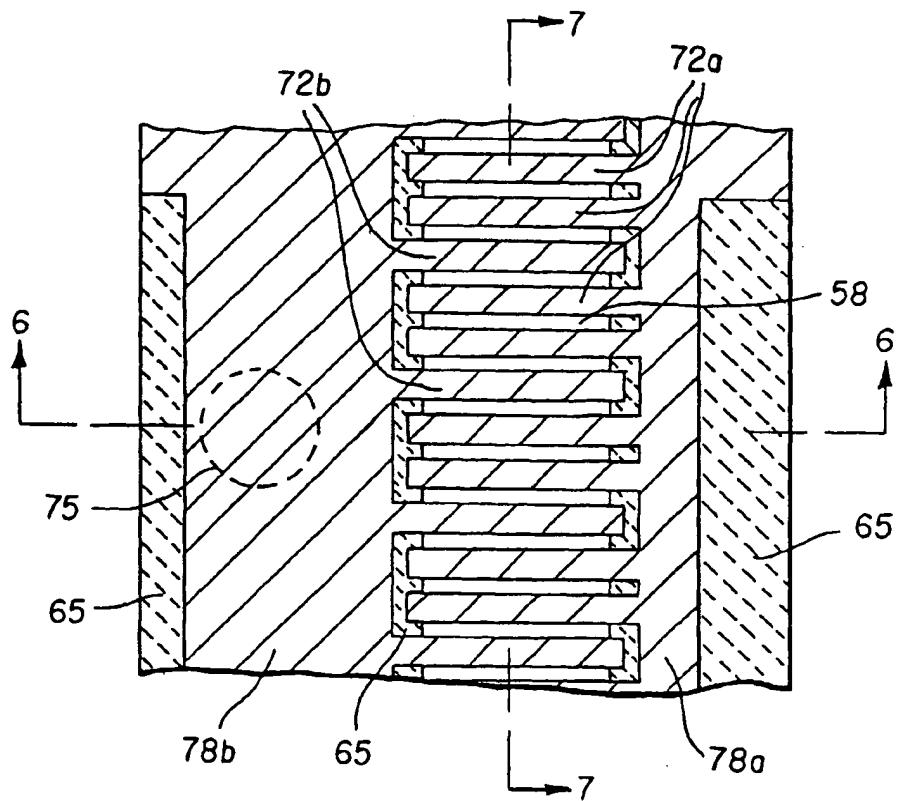
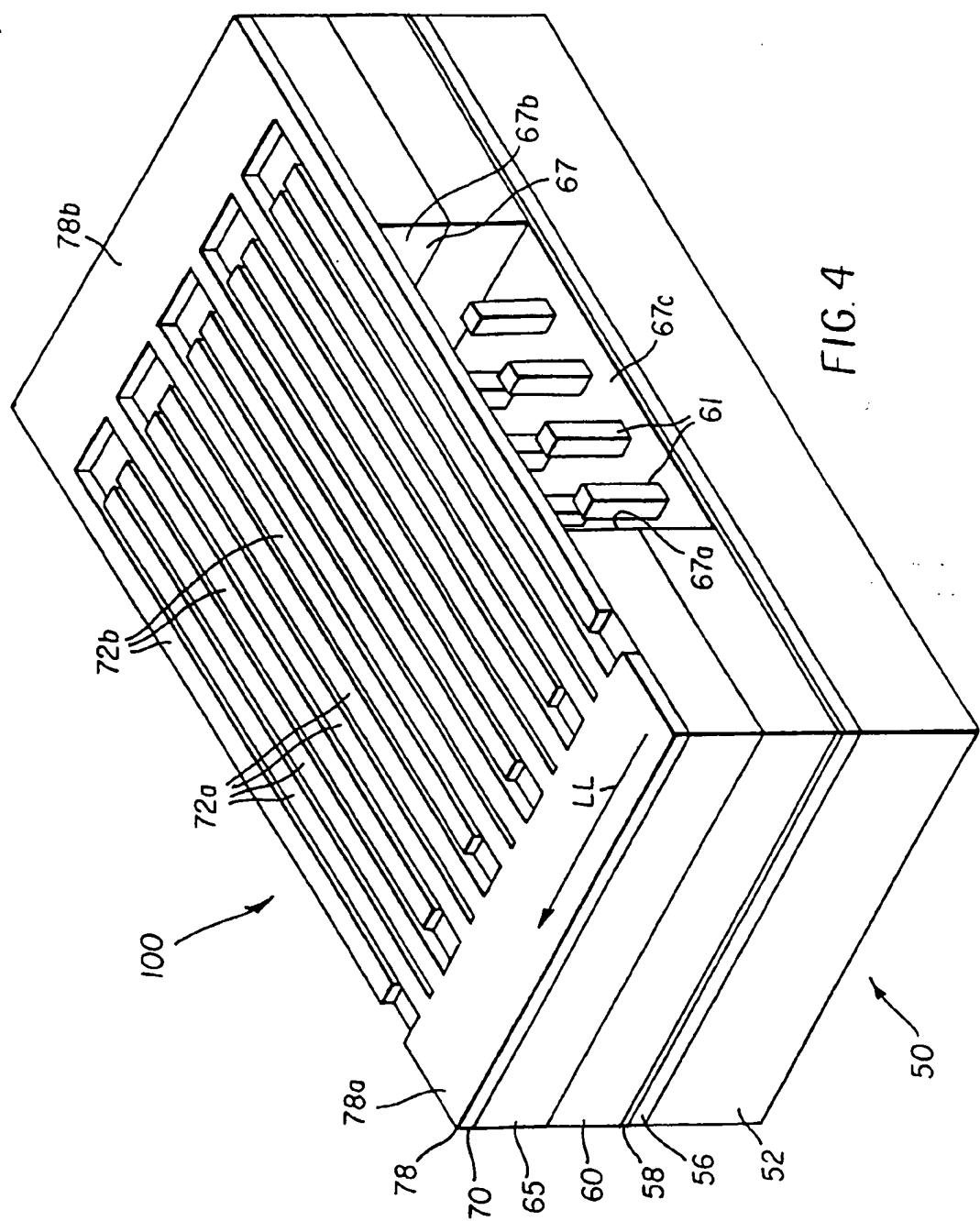


FIG. 5



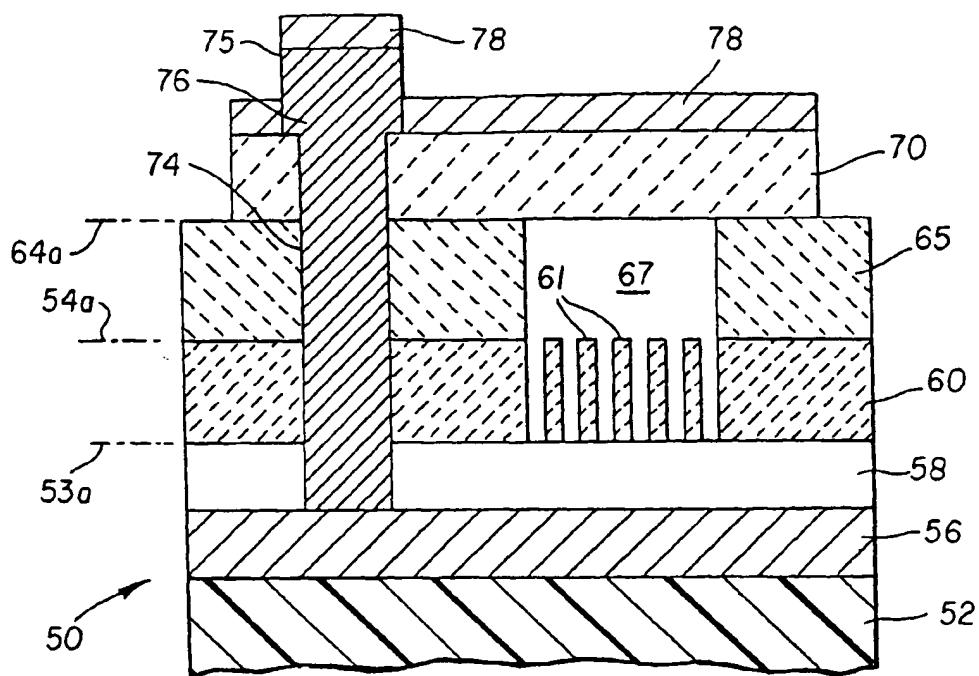


FIG. 6

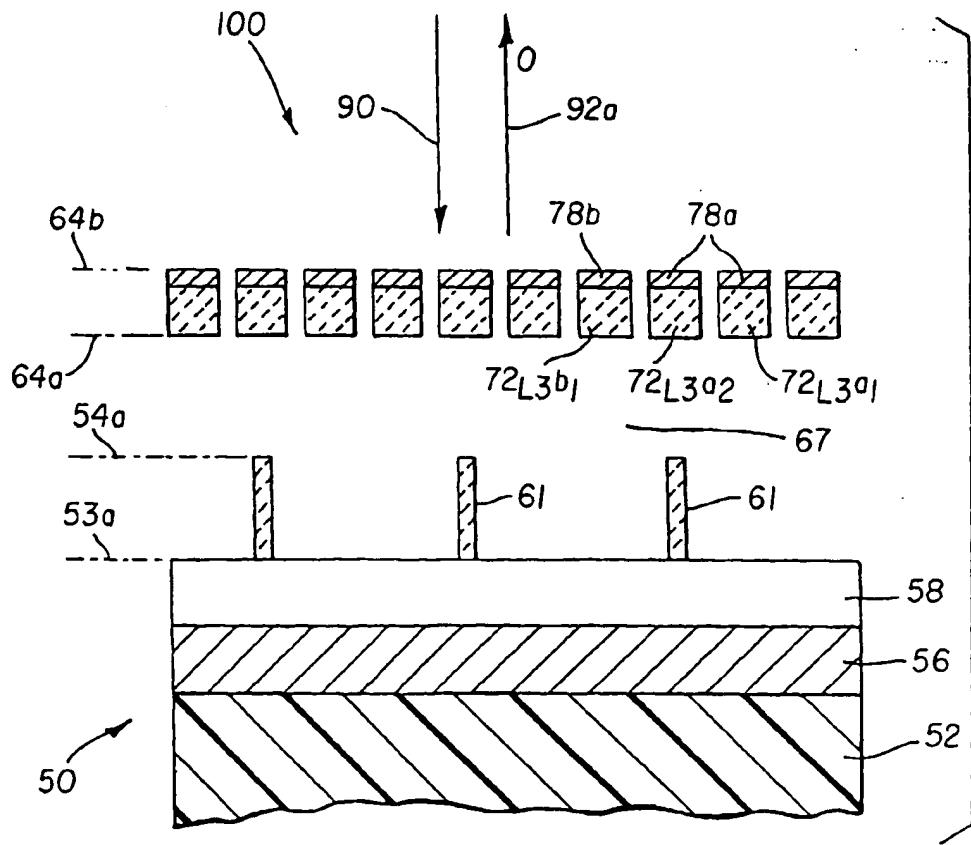


FIG. 7

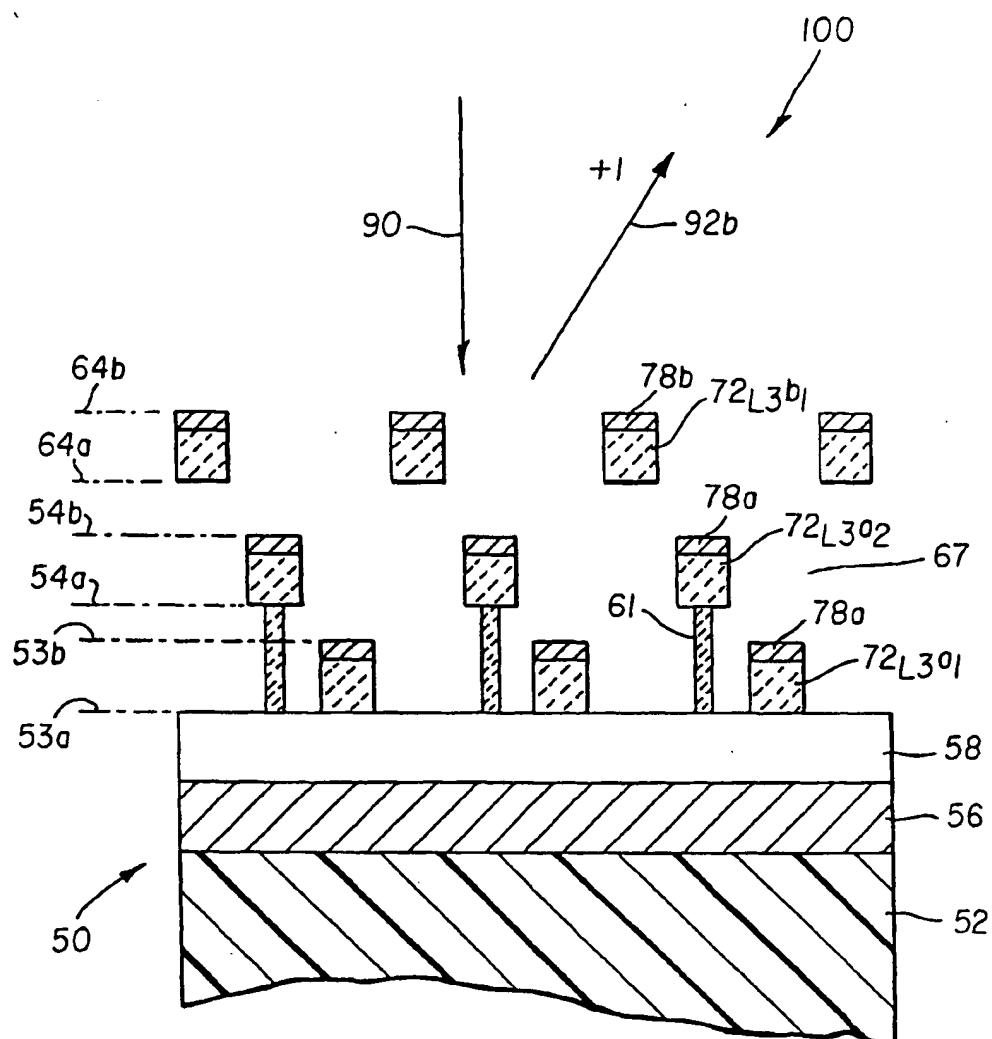


FIG. 8

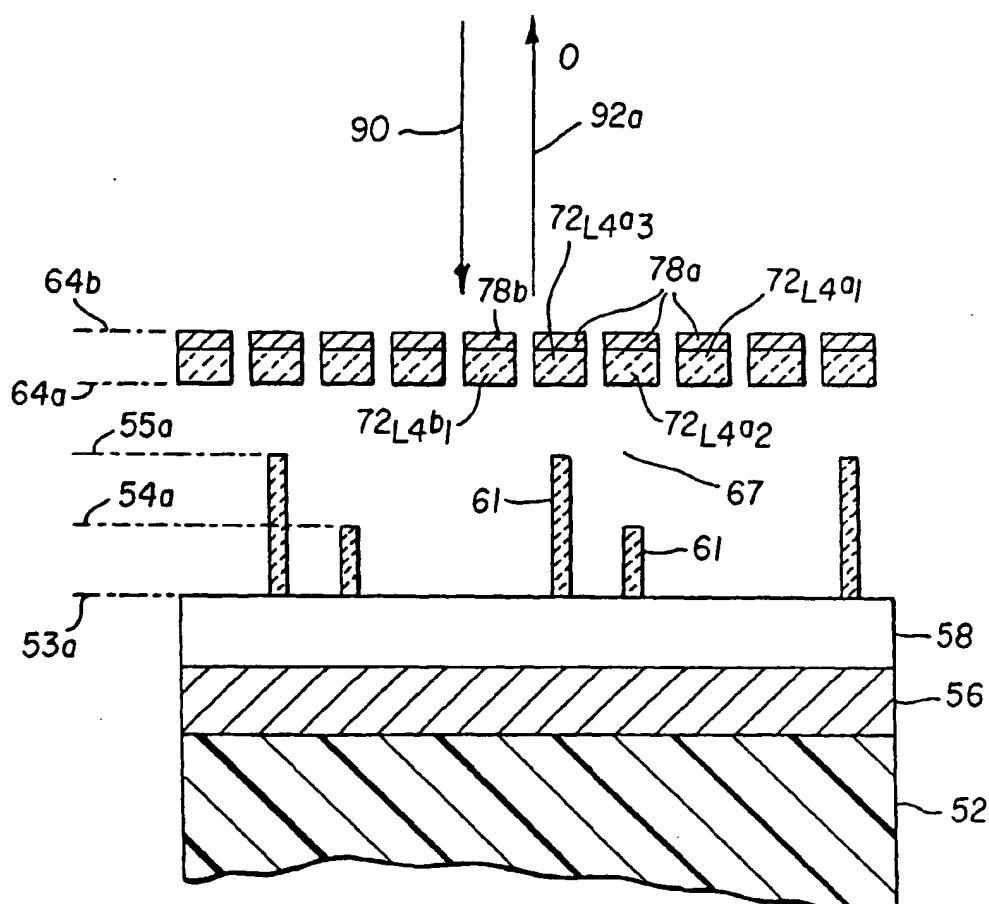


FIG. 9

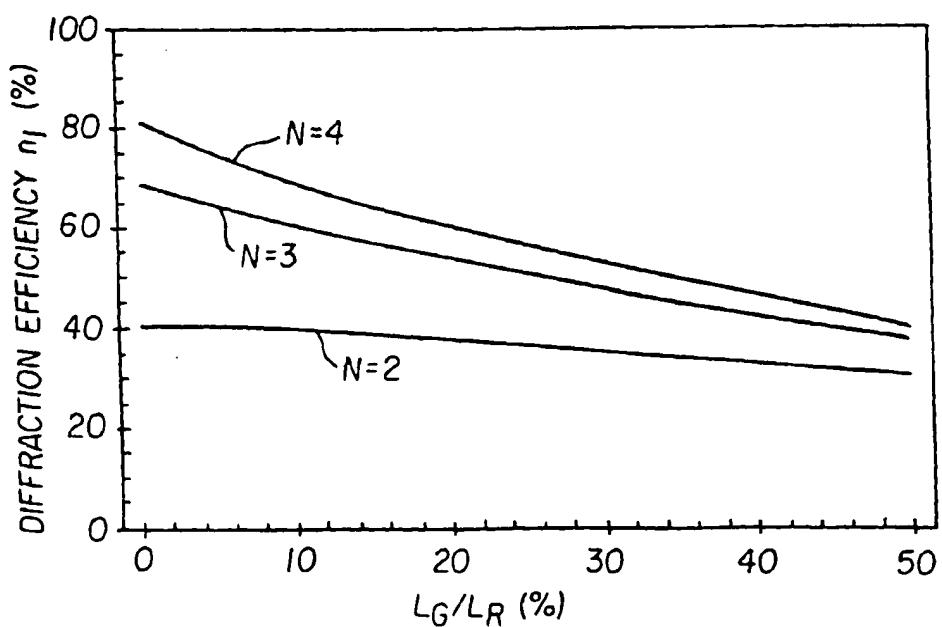
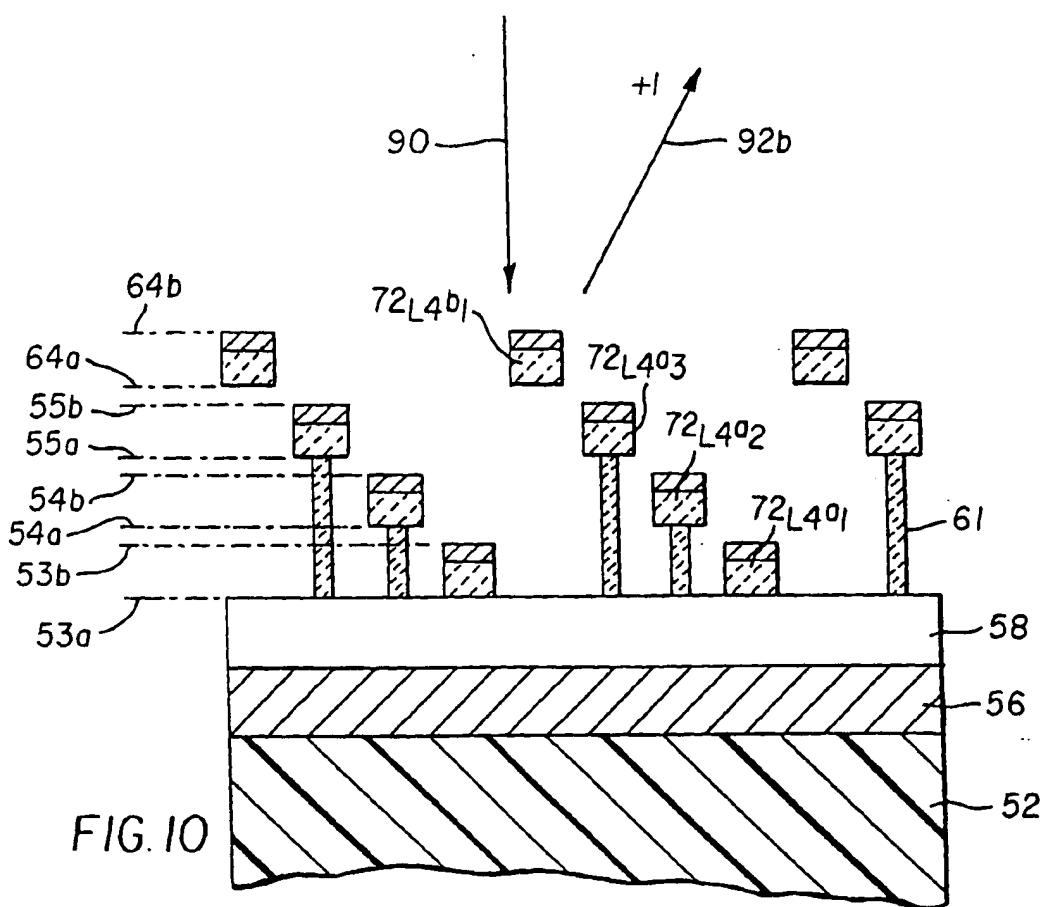


FIG. 11



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Office

EUROPEAN SEARCH REPORT

Application Number

EP 99 20 4210

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The present search report has been drawn up for all claims			
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THE HAGUE	29 March 2000	Sarneel, A	
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